

Notice of References Cited	Application/Control No. 10/801,219	Applicant(s)/Patent Under Reexamination MEGAW ET AL.	
	Examiner Y. J. Han	Art Unit 2838	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-6,838,864	01-2005	Di Iorio, Ercole	323/313
*	D	US-7,012,417	03-2006	McClure, David C.	323/318
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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